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PATENT & TRADEMARK OFFICE

#4 IDS
3/21/5

SECTION 2. FORMS PTO/SB/08A and 08B (formerly Form PTO-1449)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Wachtmann	Attorney Docket:	2550/185
Serial No:	10/670,673	Art Group Unit:	2811
Date Filed:	September 25, 2003	Examiner Name:	Not Yet Assigned
Invention:	Method of Forming a Surface Micromachined MEMS Device		

LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

U.S. PATENT DOCUMENTS					
Examiner Initials	**Reference Number**	**Document Number**	**Issue Date**	**Inventor**	**Class/Subclass**
MDP	AQ	US 5,399,415	Mar. 21, 1995	Chen et al.	428/209

OTHER DOCUMENTS			
Examiner Initials	**Reference Number**	**Author**	**Title of Article, Title of Journal, Volume Number, Page Numbers, Date**
MDP	AR	Authorized Officer Klaus Meierewert	*The International Search Report,* International Searching Authority, September 23, 2004, 6 pages.

Examiner Signature: Marcos B. Haynes

Date Considered: 5/12/2005

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation *if not* in conformance and not considered. Include copy of this form with next communication to applicant.

#1 IDS
9/25/3

SECTION 2. FORMS PTO/SB/08A and 08B (formerly Form PTO-1449)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Bruce K. Wachtmann	Attorney Docket:	2550/185
Serial No:		Art Group Unit:	
Date Filed:	September 25, 2003	Examiner Name:	
Invention:	Method Of Forming A Surface Micromachined MEMS Device		

LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT

U.S. PATENT DOCUMENTS					
Examiner Initials	Reference Number	Document Number	Issue Date	Inventor	Class/Subclass
MDP	AA	US 5,216,490	06/01/93	Greiff et al.	
	AB	US 6,021,675	02/08/00	Seefeldt et al.	
	AC	US 5,343,064	08/30/94	Spangler et al.	
	AD	US 5,578,224	11/26/96	Theresa A. Core	
	AE	US 5,639,542	06/17/97	Roger T. Howe et al.	
	AF	US 5,879,963	03/09/99	Roger T. Howe et al.	
	AG	US 5,640,039	06/17/97	Kevin Hin-Leung Chau et al.	
	AH	US 5,939,633	08/17/99	Michael W. Judy	
	AI	US 6,505,511 B1	01/14/03	John A Geen et al.	
	AJ	US 5,828,115	10/27/98	Theresa A. Core	
	AK	US 5,326,726	07/05/94	Robert W. K. Tsang et al.	
MDP	AL	US 5,858,809	01/12/99	Kevin Hin-Leung Chau et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Reference Number	Country Code	Document Number	Publication Date	Patenteee or Applicant	Class/Subclass
MDP	AM	DE	198 47 455 A1	04/27/00		
MDP	AN	EP	0 834 759 A2	08/04/98		
MDP	AO	WO	02/12116 A2	02/14/02		

OTHER DOCUMENTS			
Examiner Initials	Reference Number	Author	Title of Article, Title of Journal, Volume Number, Page Numbers, Date
MDP	AP	Timothy J. Brosnihan et al.	Embedded Interconnect and Electrical Isolation for High-Aspect-Ration, SIO Inertial Instruments; June 16-19, 1997; pp. 637-640

Examiner Signature: _____

Date Considered: 5/12/2005

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